

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Hisashi NAKAYAMA, et al.

Application No.: 10/808,396

Filed: March 25, 2004

Customer Number: 20277

Confirmation Number: 5073

Group Art Unit: 2811

Examiner: HU, Shouxiang

For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.
☐ Applicant is entitled to small entity status under 37 CFR 1.27
☐ Also attached:

The fee has been calculated as shown below:

| | NO. OF CLAIMS | HIGHEST PREVIOUSLY PAID FOR | EXTRA CLAIMS | RATE | FEE |
|---|------------------|-----------------------------------|-----------------|------------|--------|
| Total Claims | 29 | 29 | 0 | \$50.00 = | \$0.00 |
| Independent Claims | 4 | 4 | 0 | \$200.00 = | \$0.00 |
| Multiple dependent claims newly presented | | | | | \$0.00 |
| Fee for extension of time | | | | | \$0.00 |
| | | | | | \$0.00 |
| Total of Above Calculations | | | | | \$0.00 |

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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 Date: December 28, 2005

Please recognize our Customer No. 20277 as our
 correspondence address.



Docket No.: 060188-0824

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|---|---|---------------------------|
| In re Application of | : | Customer Number: 20277 |
| Hisashi NAKAYAMA, et al. | : | Confirmation Number: 5073 |
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AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 29, 2005, having a three-month shortened statutory period set to expire on December 29, 2005, please amend the above identified application as follows: